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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Chiaki SASAOKA  
Title: SEMICONDUCTOR LASER  
AND METHOD OF  
FABRICATING THE SAME  
Appl. No.: 10/549,447  
International Filing Date: 2/26/2004  
371(c) Date: 9/14/2005  
Examiner: Yuanda Zhang  
Art Unit: 2828  
Confirmation Number: 5540

**AMENDMENT AND REPLY UNDER 37 CFR 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated July 3, 2007, concerning the above-referenced patent application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this document.

**Remarks/Arguments** begin on page 5 of this document.

Please amend the application as follows: